



In the United States Patent and Trademark Office

RECEIVED #15
B 2.T

AUG 3 - 1999

Publishing Division

Applicant(s): Finarov, Moshe

Assignee: Nova Measuring Instruments

Title: APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING POLISHING

Serial No.: 09/047,944

Filed: 03/25/98

Batch No.: S39

Date Allowed: April 27, 1999

Examiner: E. Morgan

Group Art Unit: 3723

Docket No.: M-3417-1C US

San Jose, California
July 29, 1999

Box Issue Fee
ASSISTANT COMMISSIONER FOR PATENTS
Washington, D. C. 20231

PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicant respectfully petitions for a one-month extension of time within which to file the formal drawings for the above-identified application, such extension allowing the undersigned until August 27, 1999 to submit the drawings.

Please charge our Deposit Account No. 19-2386 in the amount of \$ 55.00 as set forth in the enclosed transmittal letter.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: ASSISTANT COMMISSIONER FOR PATENTS, Washington, D.C. 20231, on July 29 1999.

David W. Heid

Attorney for Applicant(s)

7/29/99

Date of Signature

Respectfully submitted,

David W. Heid

David W. Heid
Attorney for Applicant(s)
Reg. No. 25,875

LAW OFFICES OF
SKJERVEN, MORRILL,
MacPHERSON, FRANKLIN
& FRIEL LLP

25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979

539138 v1

- 1 -

SER. NO. 09/047,944

08/03/1999 TTRANE 00000204 192386 09047944
01 08:215 55.00 CH